



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Qinghong K. Gao et al.) Group Art Unit: 1763
Application No.: 10/600,273) Examiner: Not Yet Assigned
Filed: June 20, 2003) Confirmation No.: 6096
For: MULTIPLE ZONE GAS DISTRIBUTION)
APPARATUS FOR THERMAL)
CONTROL OF SEMICONDUCTOR)
WAFER)

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please advise, in writing, as to the current status of the above-captioned application.

The above application was filed on June 20, 2003 and to date no Official Action has been received by the undersigned.

Respectfully submitted,

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Date: December 21, 2004

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